

INFORMATION DISCLOSURE STATEMENT

Applicant : Tois et al.
App. No : 10/678,766
Filed : October 2, 2003
For : METHOD OF GROWING OXIDE
THIN FILMS
Examiner : Matthew J. Song
Art Unit : 1792
Conf No. : 1629

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

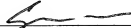
Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 21 references, of which 7 are submitted. Identification herein is not an admission that the cited references are prior art to the above-captioned application.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing of a Notice of Allowance. This Statement is accompanied by the fees set forth in 37 C.F.R. § 1.17(p). The Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 12/17/09

By: 
Gregory Tse
Registration No. 63,119
Attorney of Record
Customer No. 20,995
(415) 954-4114